

राष्ट्रीयप्रौद्योगिकीसंस्थानसिलचर National Institute of Technology Silchar

(राष्ट्रीय महत्वकासंस्थान)

(An Institute of National Importance)

www.nits.ac.in, Phone: 03842-242914, Fax: 03842-224797, Assam-788010 (INDIA)

Date: 10-04 2023

Advertisement No.: NITS/Dean(R&C)/ECE/615/01/2023

Applications are invited from Indian citizens for a temporary of post of <u>Junior Research Fellow (JRF)</u> for the **Science and Engineering Research Board (SERB)** sponsored project in the Department of Electronics and Communication Engineering, National Institute of Technology Silchar.

Title of the project	A Low Cost Fast and Reliable Clinical Prototype Based on Microwave Imaging
	for Early Diagnosis and Continuous Monitoring of Breast Cancer using
	Convolutional Neural Network
Sponsored Agency	Science and Engineering Research Board (SERB), Government. of India
Project sanction number	CRG/2022/008839
No. of posts	01
Duration	3 years
Principal Investigator (P.I)	Dr. Arnab Nandi, Department of Electronics and Communication Engineering,
	National Institute of Technology Silchar, Silchar, Assam, India, 788010. Email:
	arnab@ece.nits.ac.in Mobile: 7002270524

General Information and Terms & Conditions

1.	Age Limit	35Yrs
2.	Essential Qualification	M Tech in ECE/EI/CSE
3.	Desirable Experience	NA
4.	Salary	Rs 31,000/- per month for the first two years & Rs 35,000/- for the 3 rd year.
5.	Relaxation on qualification and age	Relaxation as per Govt of India Rules.
6.	Last date of receiving/ submission of filled up application form	25 th April, 2023
7.	Reporting	Applicants are to submit their filled-up applications along with C.V. to the PI accompanying photocopies of all relevant documents with self-attestation to the address: Dr. Arnab Nandi Associate Professor, Department of Electronics and Communication Engineering, National Institute of Technology Silchar, Silchar-788010, Assam, India (Contact-7002270524). Candidate should write "Application for the post of JRF under the project CRG/2022/008839" on the top of the envelope. Applicants are also requested to send the soft copy of the duly filled application along with C.V. & all necessary documents to the PI through email (arnab@ece.nits.ac.in) with the subject as "Application for the post of JRF under the project CRG/2022/008839" on or before 25 th April, 2023 .
8.	Date of interview, time, and venue	Interview date and mode (online/offline) will be notified in due course of time through email.
9.	No objectioncertificate	Employed candidates are to submit a no-objection certificatefrom his/her employer at the time of the interview.
10.	Institute right	The Institute has the discretion to restrict the number of candidates to be shortlisted for the interview on the basis of screening. No candidate may be recruited if suitable candidates are not found.
11.	Signing of the agreement	Selected candidates shall have to sign an agreement at thetime of joining.

Sd/-

Associate Dean (R&C)

NIT Silchar.

National Institute of Technology Silchar

FORMAT of APPLICATION

For Junior Research Fellow (JRF)

Paste recent passport size colored photograph

1.	Advertisement no.	dated:
2.	Title of the Project-	
3.	Department:	
4.	Name of the applicant (in block letters):	
5.	Father's/Husband's Name:	
6.	Date of Birth (DD-MM-YYYY):	
7.	Age (25-04-2023):	
8.	Postal Address:	
	E-mail:	Phone no.:
9.	Permanent Address:	
10.	. Nationality:	
11.	. Marital Status:	
12.	a. Whether belongs to SC/ST/PwD/OBC/EWS: (If yes, a	ttach certificate):
13.	. Educational Qualification: (Starting from Class X)	

Exam. passed	Board/ University	Divi sion	% age of marks / CPI	Year of passing	Subjects

14. NET/GATE Examinations Passe	d:
---------------------------------	----

	I. NE	Γ	II.	GATE	
Subject	Qualifying date	Valid upto	Subject	Score	Valid upto

15. Details of employments:

S1. No.	Name of the Organization	Name of the post	Period	Scale of pay and present pay	Nature of duty

16. Any other relevant information that you may like to furnish:

Declaration

I	declare	that the	e above	informatio	n are true	e and cor	rect to th	he best o	of my	knowled	ge and	belie	f.
•	acciaic	titut tit	caborc	muominatio	n arc trac	L uita coi	i cci to ti	ic best	JI III.y	MIC WICG	.gc arra	CLIC	·T•

Date:

Place Signature of the applicant